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	Efficient Approximation Machine-specifc Approach for Automatic Classifcation of Cutting Process Efficiency Meta-analysis of Maintenance Knowledge Assets Towards Predictive Cost Controlling of Cyber Physical Production Systems Towards Autonomously Navigating and Cooperating Vehicles in Cyber-Physical Production Systems.
Sommario/riassunto	The work presents new approaches to Machine Learning for Cyber Physical Systems, experiences and visions. It contains some selected papers from the international Conference ML4CPS – Machine Learning for Cyber Physical Systems, which was held in Lemgo, October 1-2, 2015. Cyber Physical Systems are characterized by their ability to adapt and to learn: They analyze their environment and, based on observations, they learn patterns, correlations and predictive models. Typical applications are condition monitoring, predictive maintenance, image processing and diagnosis. Machine Learning is the key technology for these developments.